



LIST OF PUBLICATIONS
CITED BY THE APPLICANT

Attorney Docket No.
0360-0033 (F7-5537)

Serial No.
09/457,173

Applicant
James D. Jacobson

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Filing Date
December 8, 1999

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1723

OTHER PUBLICATIONS

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JK

English abstract re Japanese Patent Application JP 03-060713 A published March 15, 1991.

JK

TRAUTMANN, C. ET AL "Pore Geometry of Etched ION Tracks in Polyimide," *Nuclear Instruments & Methods in Physics Research, Section - B: Beam Interactions With Materials and Atoms*, vol. 111, no. 1, April 1, 1996, North Holland Publishing Company, Amsterdam, NL.

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